



IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/565,006

Confirmation No.:

In re Application of:

Yasuyo SOGAWA, *et al.*

Group Art Unit:

Filed: January 18, 2006

For: SEMICONDUCTOR INTEGRATED CIRCUIT

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Customer Window
U.S. Patent & Trademark Office
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Further to the Information Disclosure Statement filed on April 18, 2006 wherein Japanese Patent Application No. 52-67741 was cited, filed herewith is a statement provided by applicants' Japanese patent attorney.

Respectfully Submitted,

STEPTOE & JOHNSON LLP


Roger W. Parkhurst
Registration No. 25,177

January 8, 2007

RWP/lmw

Attorney Docket: 28951.1169

STEPTOE & JOHNSON LLP
1330 Connecticut Ave., N.W.
Washington, D.C. 20036
(202) 429-6420

FORM 1449 (S&J Version)	Docket No.: 28951.1169
INFORMATION DISCLOSURE STATEMENT	
BY APPLICANT	
14P3A	Applicant: Y. SOGAWA et al.
	Application No.: 10/565,006
	Filing Date: 01/18/2006
	Examiner: _____
	Group Art Unit: _____

APR 18 2006

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS

Examiner's Initials*	Include author, title of article, title of item (book, journal, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

Examiner's Signature	/Latanya Crawford/	Date Considered	05/11/2007
----------------------	--------------------	-----------------	------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.